

**Notice of References Cited**

Application/Control No.

10/562,790

Applicant(s)/Patent Under

Reexamination

MURPHY ET AL.

Examiner

BEN H. LIU

Art Unit

2616

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**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-5,815,689 A	09-1998	Shaw et al.	713/400
*	B US-6,327,274 B1	12-2001	Ravikanth, Rayadurgam	370/516
*	C US-2003/0072310 A1	04-2003	Reme, Jean-Marc	370/394
*	D US-6,643,496 B1	11-2003	Shimoyama et al.	455/69
*	E US-2004/0090994 A1	05-2004	Lockridge et al.	370/509
*	F US-2004/0252235 A1	12-2004	Ejima, Naoki	348/515
*	G US-7,088,398 B1	08-2006	Wolf et al.	348/423.1
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	
V	
W	
X	

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